

Faculty Position, Assistant Professor

Public offering of Faculty Position, Assistant Professor

Position Title	Assistant Professor
Affiliation	Advanced Materials, Precision & Intelligence Laboratory
Research Field	Material chemistry for design & fabrication of electronic device, including (1) metallic materials (2) mechanical evaluation, (3) crystallographic analysis and (4) electrochemistry. Key words: micro/nano materials, Cu alloys, light metals, processing, thin films, electrochemistry, surface & interface, nano structure, mechanical properties of materials
Requirements	<ol style="list-style-type: none"> 1. Applicants must have Ph.D. or Doctoral degree or will have the degree till September 30th, 2012 in an area related to the above specified field. 2. Applicants must have superior professional experiences in the above specified field and contribute to supervise Doctoral candidates. 3. Applicants must have ability to teach undergraduate and graduate courses (in Japanese or English) in the above specified field.
Expected Start Date	The earliest convenience in the academic year of 2012
Period of employment	Until 10 years after start date (the researcher can be employed for next 5 years if successful at a review assessment held in the 10th year of the term.)
Documents for the Application	<p>(hard-copy)</p> <ol style="list-style-type: none"> 1. A Curriculum vitae with photograph, including education records, professional career records, doctoral degree, awards, e-mail, and postal address. 2. A publication list (Categorized into refereed (peer-reviewed) journals, refereed conference papers, books, review papers, invited lectures, significant academic activities, patents, funding obtained, and other specific activities). 3. Reprints or copies of significant articles (3 best articles). 4. Brief statement (2 pages in A4 sheet) of research achievements. 5. Brief statement (2 pages in A4 sheet) of research plan. 6. Two reference persons (name, affiliation, and contact address).
Application Deadline	June 24th, 2012
Mailing Address for the Application and Inquiries	<p>Professor Tatsuo Sato</p> <p>Precision & Intelligence Laboratory, Tokyo Institute of Technology, R2-18, 4259, Nagatsuta, Midoriku, Yokohama 226-8503, Japan.</p> <p>Phone : +81-45-924-5044 or +81-45-924-5043</p> <p>E-mail: sato.sone.lab[at]ames.pi.titech.ac.jp (please exchange from [at] to @)</p>
Notes	<p>Applicants should send the application documents by postal mail or courier service.</p> <p>On the envelope, write "Application Documents for the Assistant Professorship" in red. We do not accept e-mail application. The documents are not returned.</p>